

DAMIC-M: search for light dark matter with CCDs

Paolo Privitera

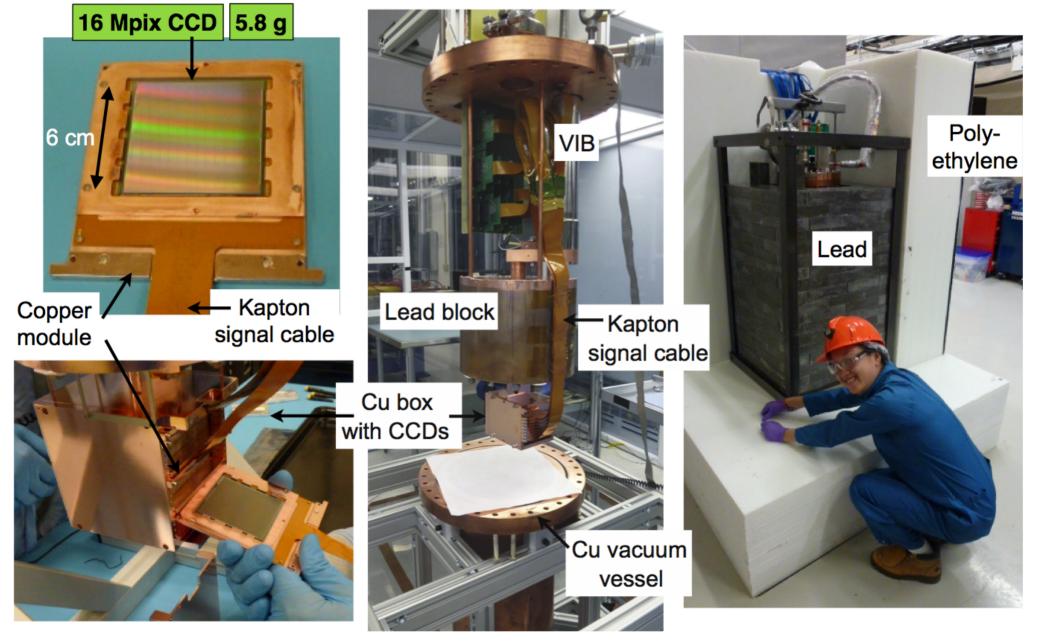


(Photo image: particle tracks in a DAMIC CCD)

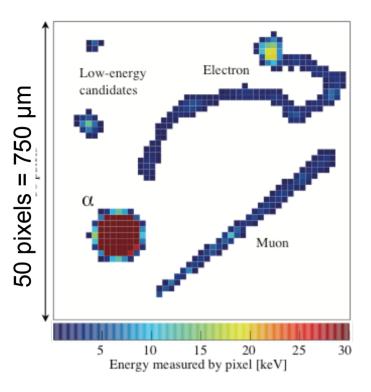
OANCH

Dark Matter in CCDs @ SNOLAB

15 μ m x 15 μ m pixel, 675 μ m thick



DAMIC-M (DAMIC at Modane) builds on the experience of DAMIC at SNOLAB

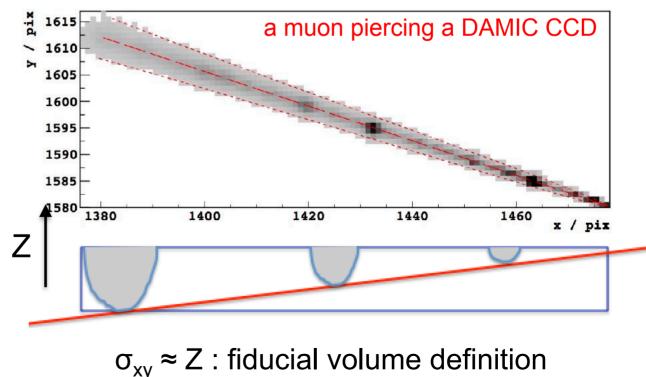


3D reconstruction of energy deposit within the silicon bulk using charge diffusion

DAMIC CCDs

Exquisite spatial resolution

Allows for unique particle identification and background characterization



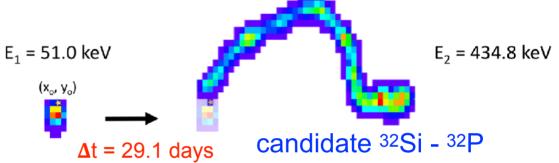
• Cosmogenic ³²Si

Produced by cosmic rays in the atmosphere, ends up in the silica sand.

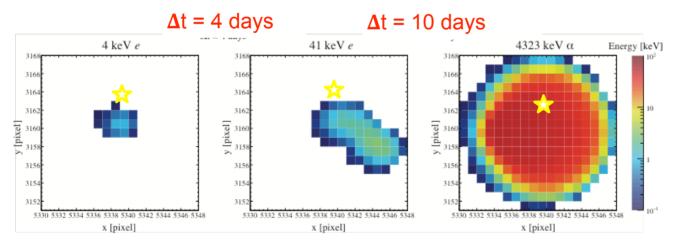
Search for spatially correlated beta decays. Sensitivity with current data is few Bq/kg

Unique capability to characterize (and reject) backgrounds

³²Si (T_{1/2}= 150 y, β)
$$\rightarrow$$
 ³²P (T_{1/2}= 14 days, β)



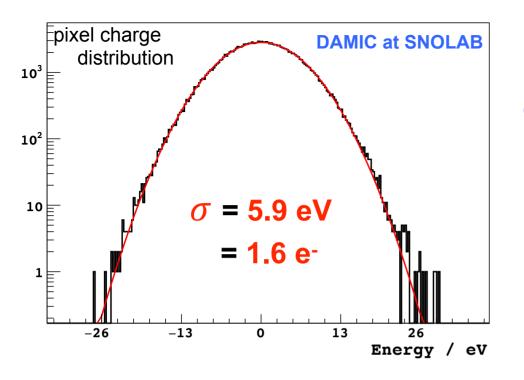
• Bulk and surface radiogenic backgrounds



sub-ppt levels sensitivity to bulk contamination

candidate ²¹⁰Pb decay chain

²¹⁰Pb (T_{1/2}= 22.3 y, β) \rightarrow ²¹⁰Bi (T_{1/2}=5.0 days, β) \rightarrow ²¹⁰Po (T_{1/2}= 138 days, α)

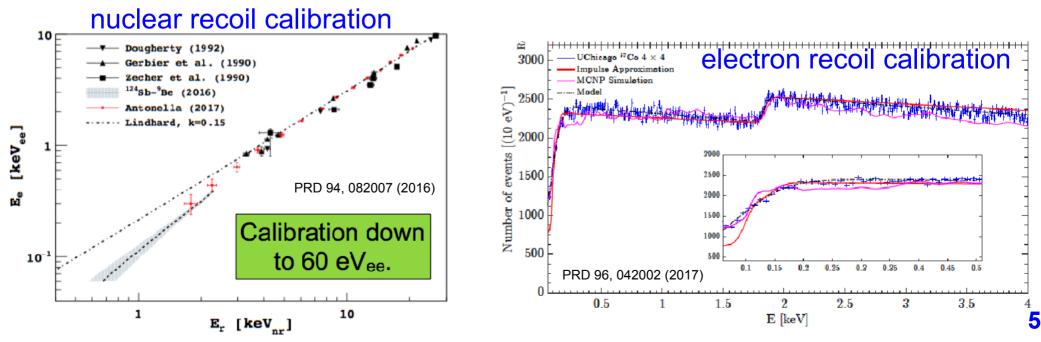


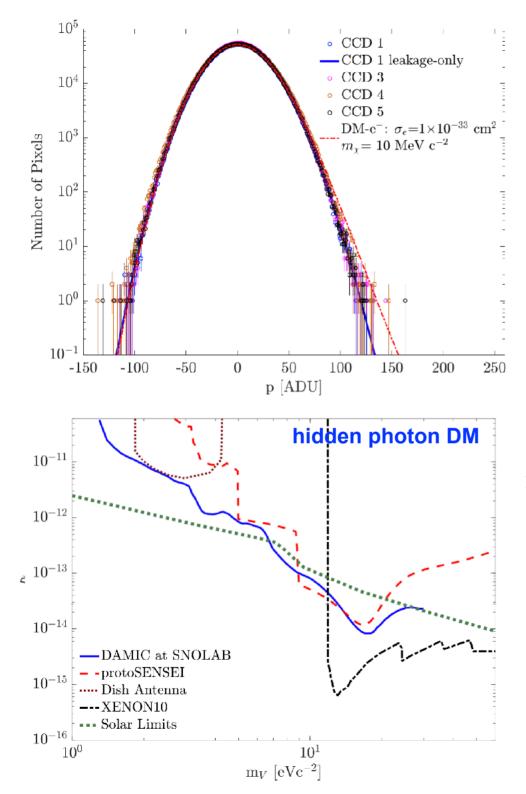
extremely low noise and dark current

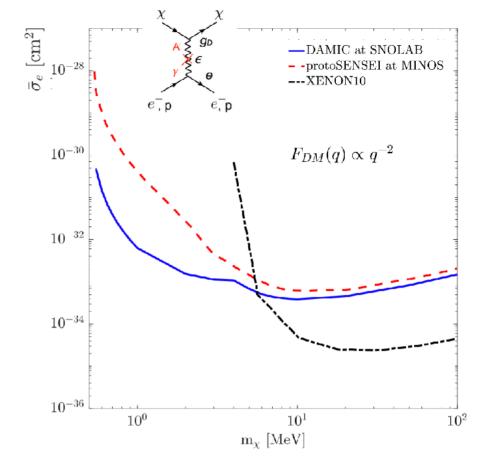
lowest dark current ever measured in a silicon detector:

2 x10⁻²² A/cm² (at 140 K)

calibrated down to threshold





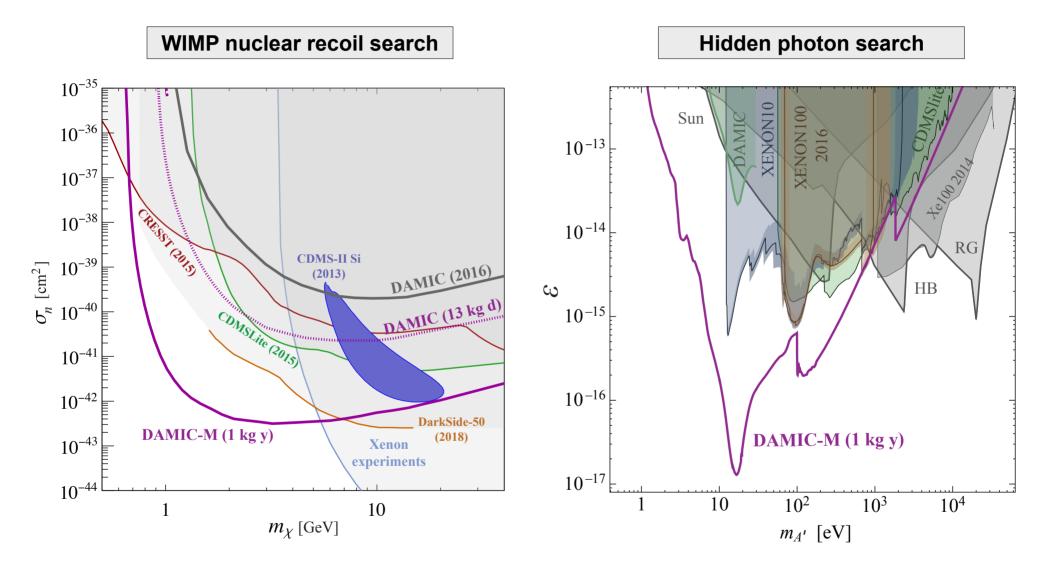


Phys. Rev. Lett. 123, 181802 (2019)

DM-electron limits

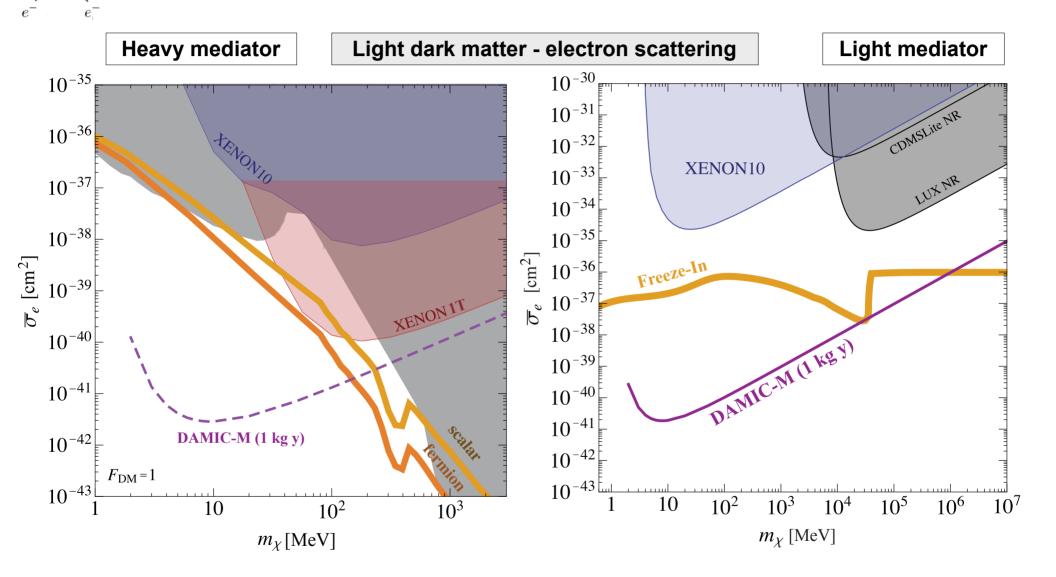
DAMIC@SNOLAB has established world-best limits thanks to the extremely low dark current and threshold

Scientific reach



DAMIC-M will feature <u>single electron</u> resolution allowing for detection thresholds of 2-3 e-

Scientific reach



DAMIC-M will be sensitive to light dark matter even if these candidates constitute only a small fraction of the total DM in the universe

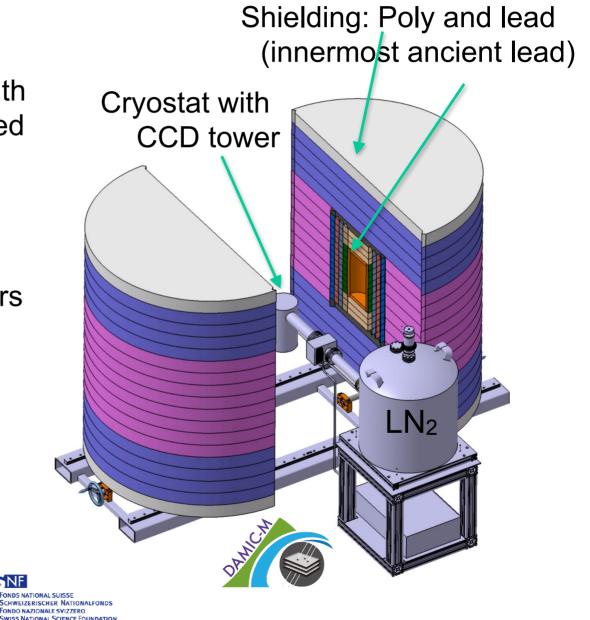
DAMIC-M

DAMIC at Laboratoire Souterrain de Modane

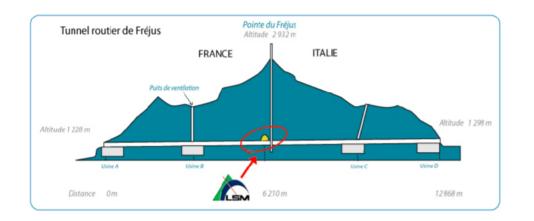
- 50 CCDs (kg-size target mass)
- Most massive CCDs ever built (>10 g each)
- Single electron resolution with "skipper" readout (demonstrated by Fermilab SENSEI group)
- A fraction of dru background
- "Classical" design (Ge detectors and DAMIC at SNOLAB)
- R&D and design up to 2021
- Construction 2022
- Installation in 2023



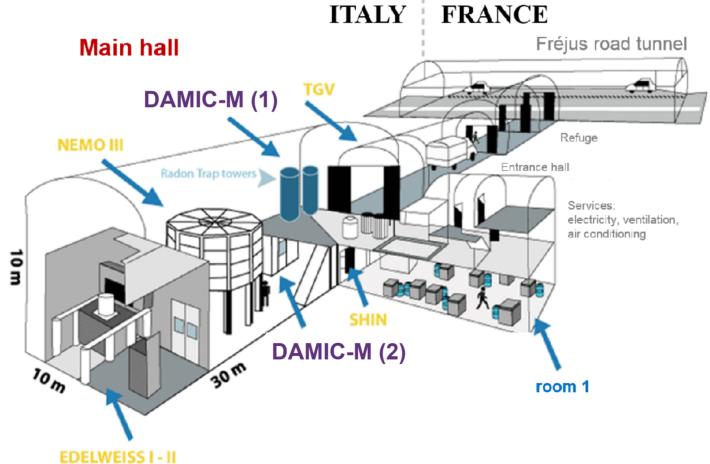




The Laboratoire Souterrain de Modane







DAMIC-M infrastructure at the

DAMIC-M (1)

On the upper floor an ISO 5, <u>radon-free</u> clean room will host the CCD packaging and test facilities



DAMIC-M (2)

The detector will be installed in an ISO 5 clean room located on the ground floor on the side of SuperNemo. DAMIC-M clean room will be installed by the end of 2019

The journey has begun!

Silicon Ingot production by TOPSIL, Frederikssund, Denmark

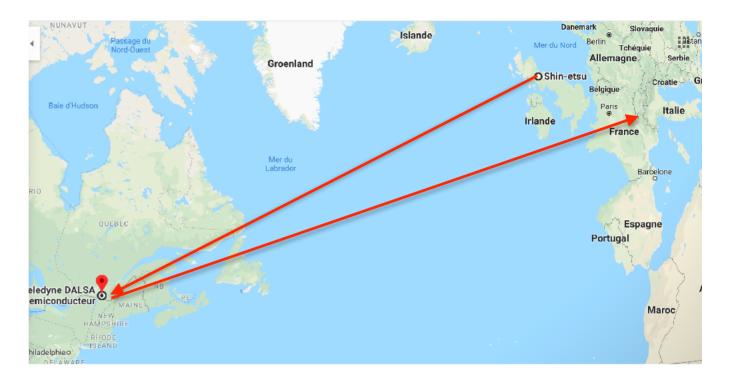
	21/00/2010 22:00 > 22/00/2010 11 15	the second se		
Float Zone mono pulling	21/08/2019 23:00 -> 22/08/2019 11:15	1000		
Crystal splitting into ingot sections and mono test	22/08/2019 11:15 -> 22/08/2019 13:00	TOPSA		
Ingot surface grinding	22/08/2019 13:00 -> 22/08/2019 15:00	THE REAL PROPERTY OF THE PROPE	INTERNAL I	
Ingot electrical tests	22/08/2019 15:00 -> 23/08/2019 11:30		These Western	
Package and invoicing	23/08/2019 11:30 -> 23/08/2019 14:30	100		
Ingot shipped (picked up by car).	23/08/2019 14:30 shipped to Boulby Und	ordround	transported	A DESCRIPTION OF THE OWNER OF THE
		a second s		
for wafering by Shin- Etsu Handotai Europe (Livingston, Scotland)	Royatame - Uni Du Nond Du Nond Ile de Man Dublin Manchesters Dreisool PAVS DE GALLES Code Souther Rotterds Souther Rotterds Souther Rotterds Souther Rotterds Souther Rotterds	Hill Bosters Light Bosters Hambourg Britters Britters Britters Durphold Oblighters United States Light Durphol	TOPS	SiL
Etsu Handotai Europe	DU NORD Ile de Man Dublin Manchesters Dublin Manchesters Diversool ANGLETCRRE PAYS DE Datues Calles Calles Dodde Ca	Hill Booters Users Decision Hantburg Decision Brief Barbourg Decision Decision Francfort are feetdain Francfort are feetdain	Restospitalet	

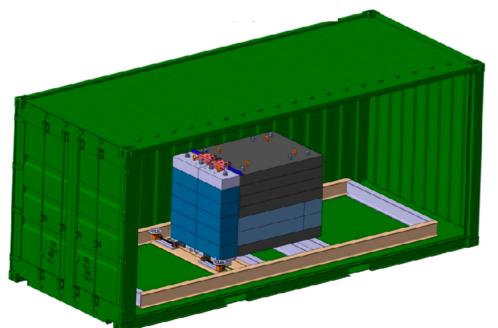
and will continue!

DAMIC-M CCDs are fabricated by Teledyne DALSA in Canada

The wafers and CCDs will be shipped by sea in a custom-made shielded container

(8-15 days transatlantic journey)





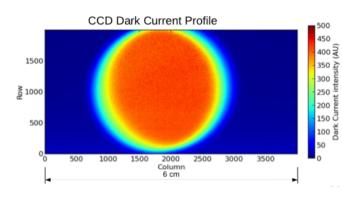
A 20' standard dry container with a \approx 15 t iron shielding. A cavity 50 cm x 40 cm x 110 cm large enough for the CCD packages and the electroformed copper cryostat

The shielding reduces tritium cosmogenic activation by a factor ≈ 25

Underground storage at SNOLAB for wafers/ CCDs while in North America

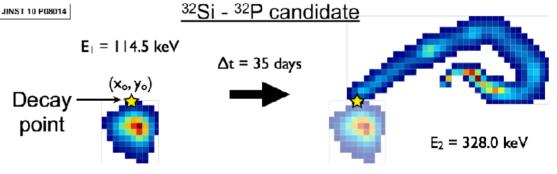
DAMIC-M Backgrounds

- Most relevant backgrounds identified by DAMIC at SNOLAB
- Cosmogenic tritium: minimize exposure to cosmic rays with shielding during transport/fabrication; CCD packaging and test underground at LSM. Also, R&D ongoing to evaluate tritium removal by wafers/CCDs baking.



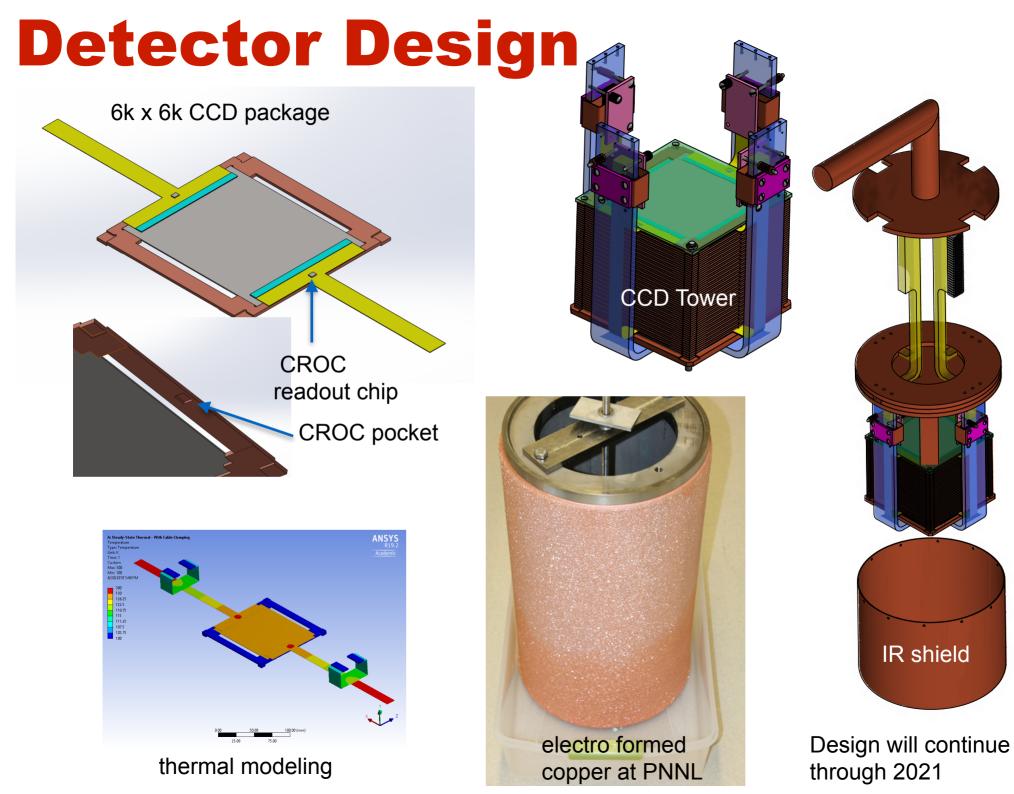
Activation of a DAMIC CCD at the LANSCE neutron beam. Tritium clearly detected; rate measurement being finalized.

 Cosmogenic ³²Si: spatial correlations



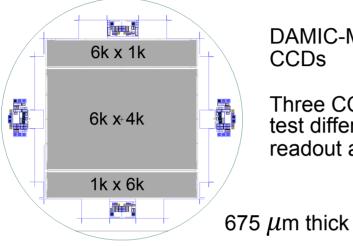
- Surface ²¹⁰Pb: minimize exposure to radon (radon-free clean room at LSM for CCD packaging/test; installation in radon-free tent)
- Radiogenic background: material selection and electro formed copper

Challenging goal: 0.1 dru



DAMIC-M CCDs

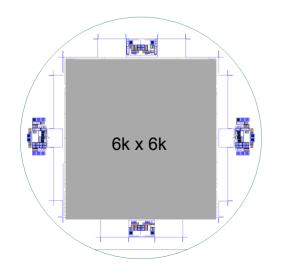
design by S. Holland (LBNL), fabricated by Teledyne/DALSA

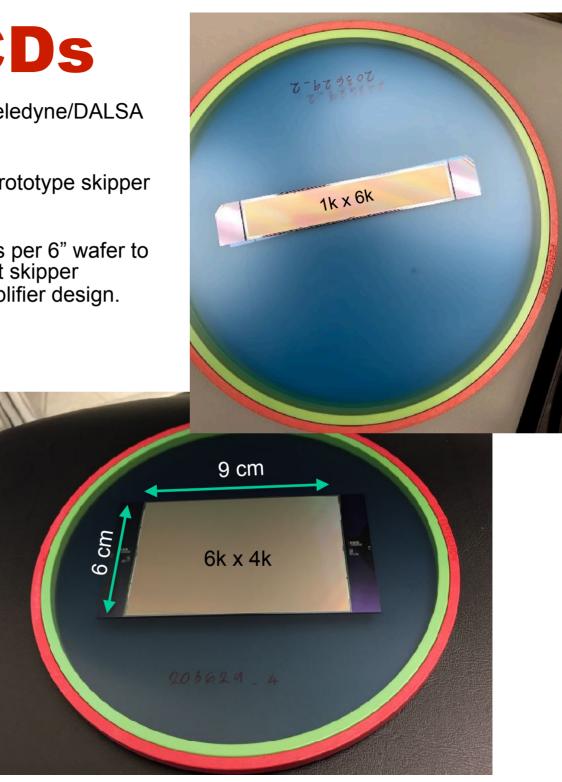


DAMIC-M prototype skipper **CCDs**

Three CCDs per 6" wafer to test different skipper readout amplifier design.

DAMIC-M production skipper CCD design 9 cm x 9 cm

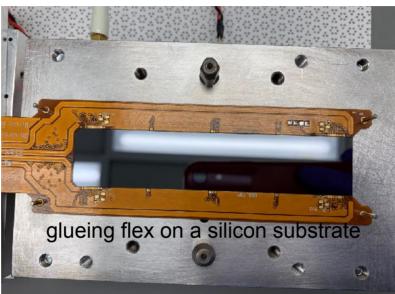


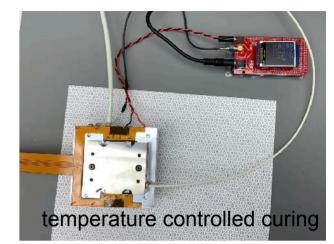


CCD Packaging

1k x 6k DAMIC-M prototype CCDs

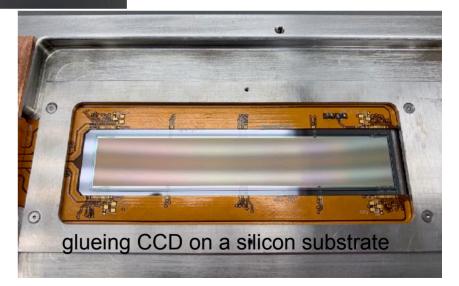






Improvement of packaging procedures originally developed for DAMIC at SNOLAB, notably by reducing the curing (and potential exposure of CCDs to radon) from a day to few hours





Low background procedures will be implemented for the pre-production and production CCDs (the main objective of the DAMIC-M CCD prototypes is demonstrating single-electron resolution and selection of best skipper amplifiers for the production)

Low-background cables



Flex cable R&D: minimize mass close to CCD; develop clean fabrication procedures for multilayer flex (PNNL)

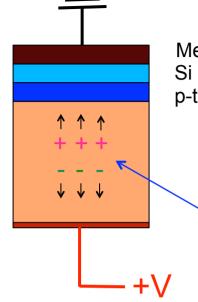
Wire bonding connector bonding area can be aiusted in arranger Hermaphrodic Wire length : arround 50 cm connector Cables bundle 1 - 18 x Twist pin contacts 5 - 36 x Picocoax Parts list 1 - 18 x Socket contacts 3 - NanoD 36 ways hermaphrodic shell XON' PRELIMINARY DRAWING NanoD crimped solution 36 signals with picccoax MIC-B.pc \odot **COFNB**

We are also pursuing with AXON a solution employing picocoaxial cables (lowbackground demonstrated by MAJORANA)

Both would fulfill our requirements for cables' radio purity

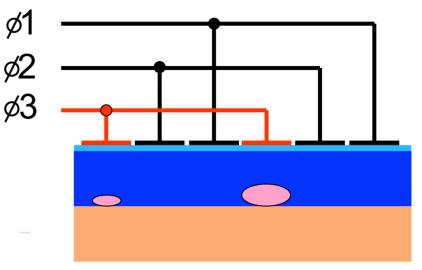
Charge Coupled Device

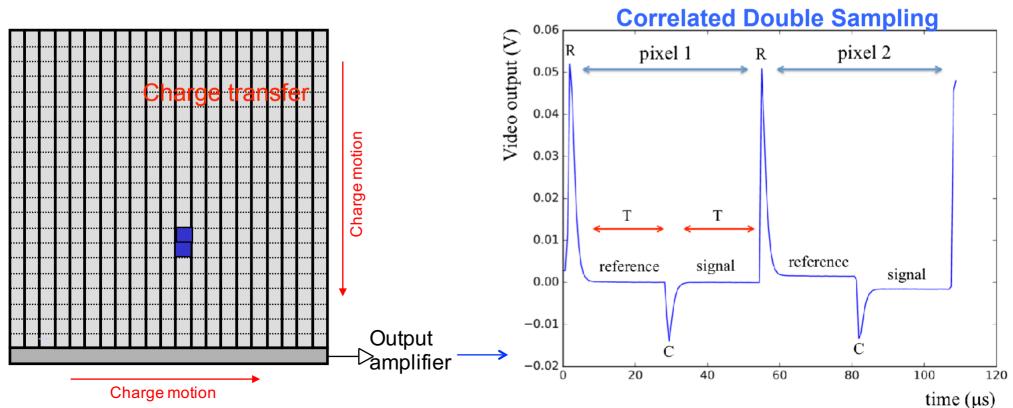
Charge transfer ("Clocks")



Metal gate Si oxide (insulator) p-type Si (buried channel)

n-type Si

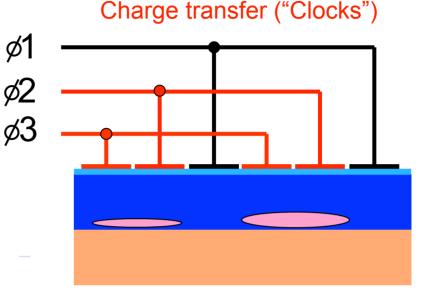


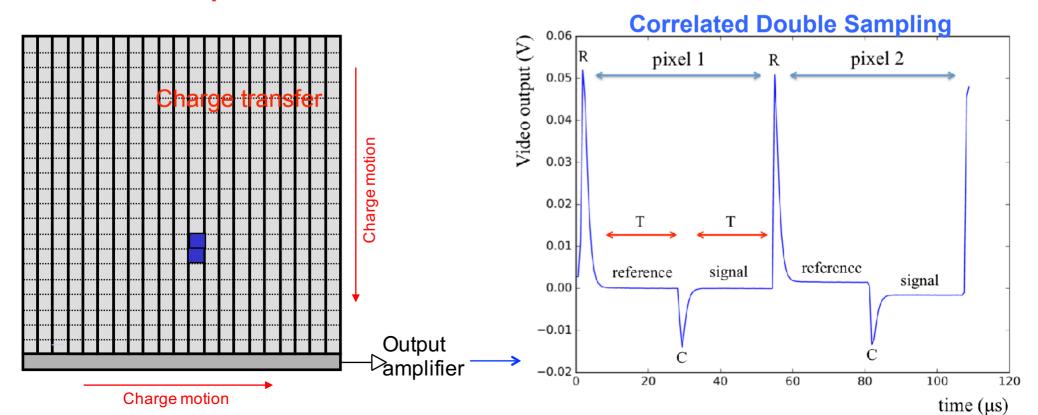


Charge Coupled Device

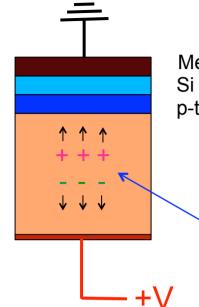
Metal gate Si oxide (insulator) p-type Si (buried channel)

n-type Si



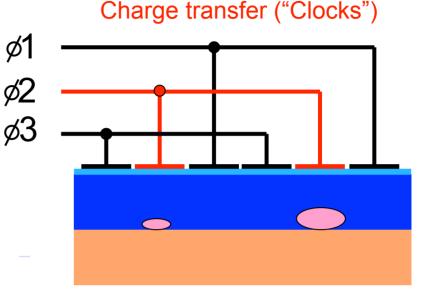


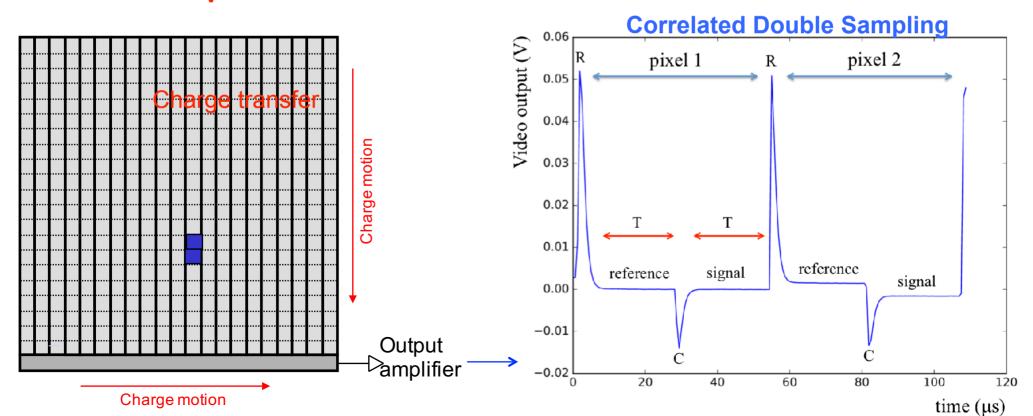
Charge Coupled Device



Metal gate Si oxide (insulator) p-type Si (buried channel)

n-type Si

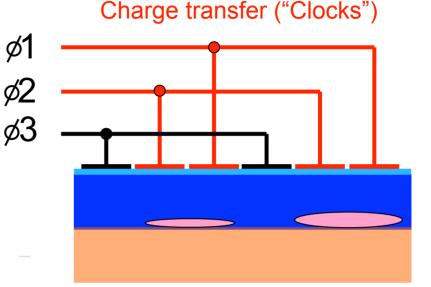


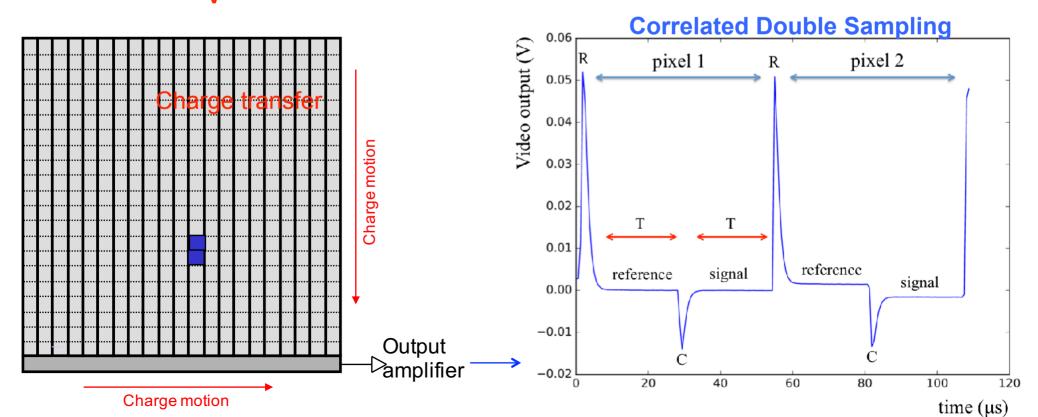


Charge Coupled Device

Metal gate Si oxide (insulator) p-type Si (buried channel)

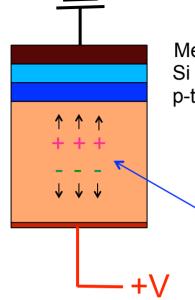
n-type Si





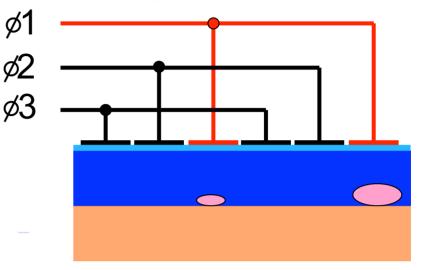
Charge Coupled Device

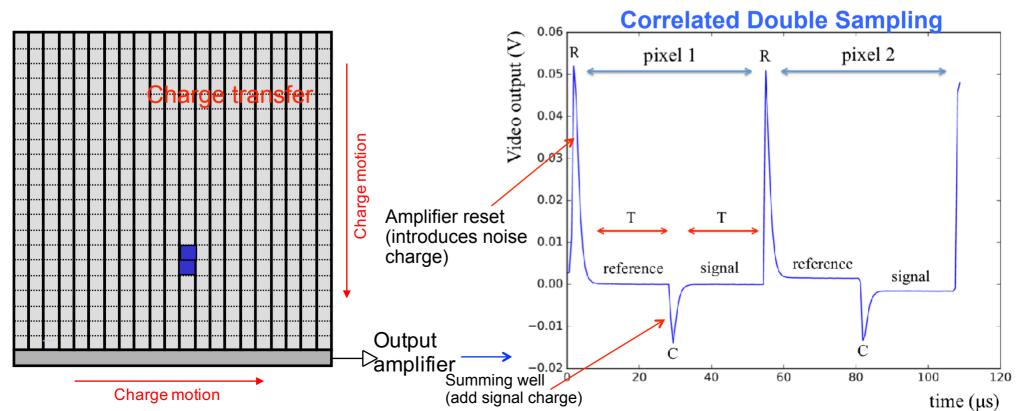
Charge transfer ("Clocks")



Metal gate Si oxide (insulator) p-type Si (buried channel)

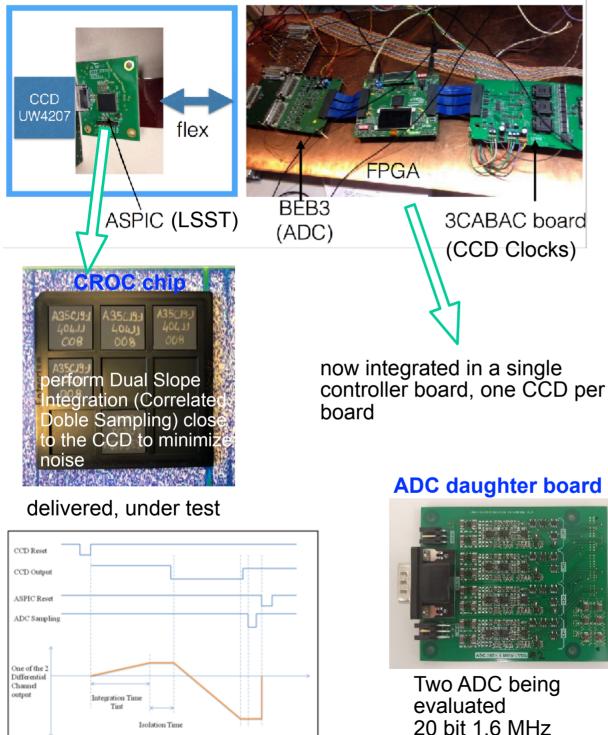
n-type Si





Dewar

Fig 1 Dual Slope Integration sequence

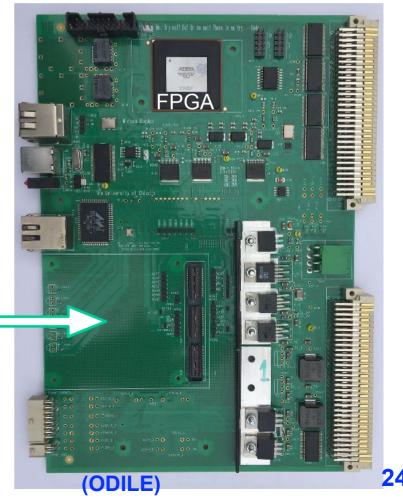


18 bit 15 MHz

Electronics

successful test of CCD Controller components (CABAC ASIC for clocks, ADC, ASPIC chip for CDS)

CCD Controller Mother Board



Skipper CCD readout

Noise in a regular CCD is dominated by the 1/f low frequency noise of the output amplifier

Non-destructive charge measurement! (NDCM)

Measure the charge fast (kill 1/f noise) and N times (noise \thickapprox 1/ $\!\sqrt{N}$)

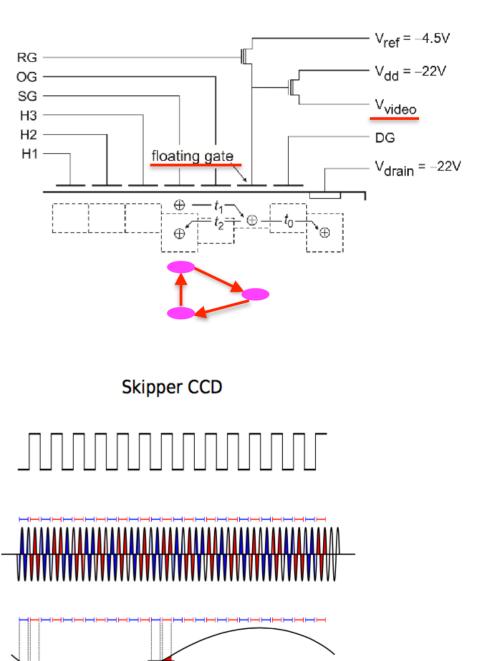
reference

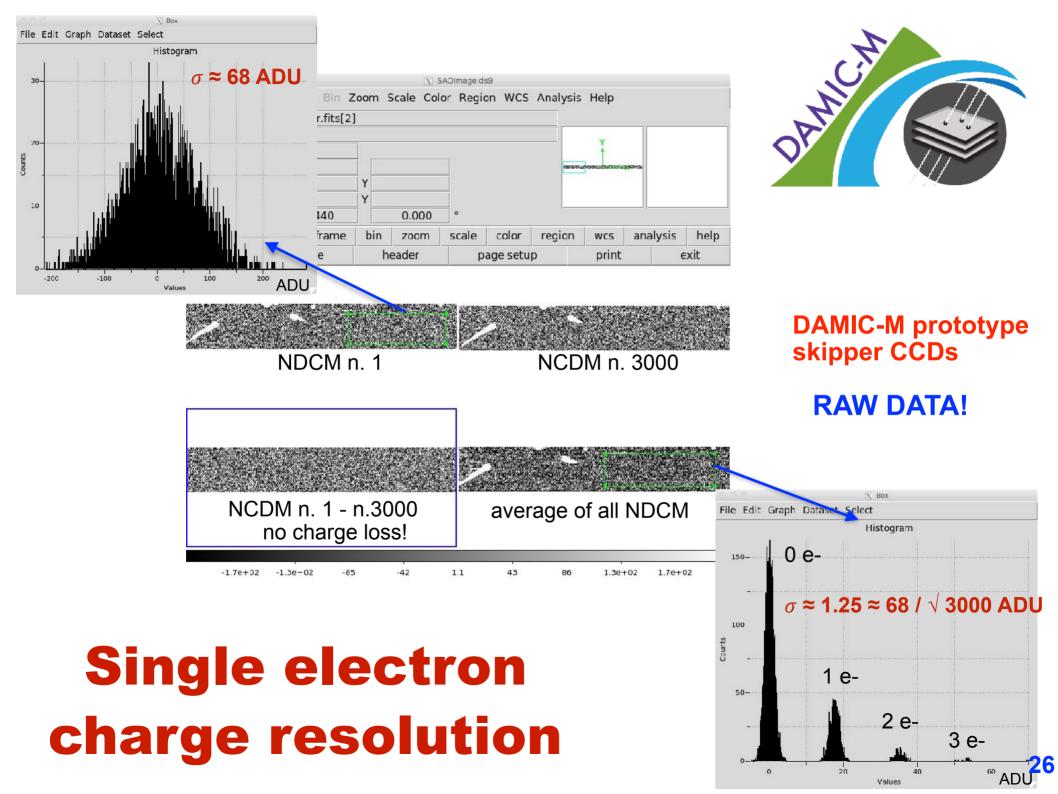
pixel charge measurement

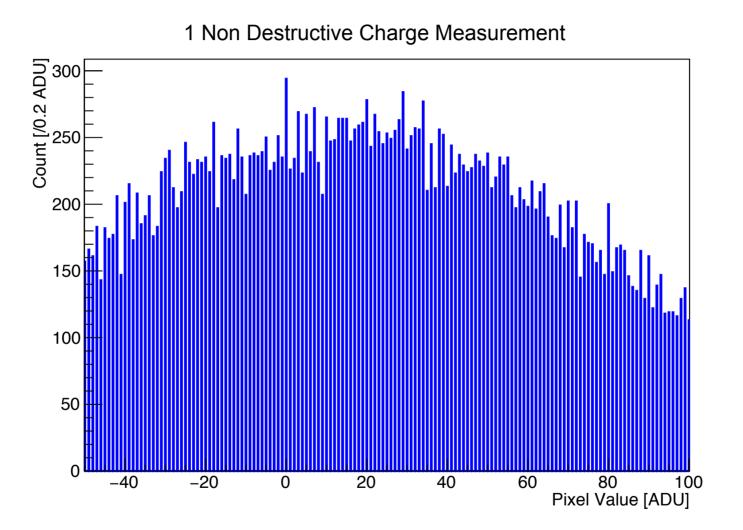
high frequency noise

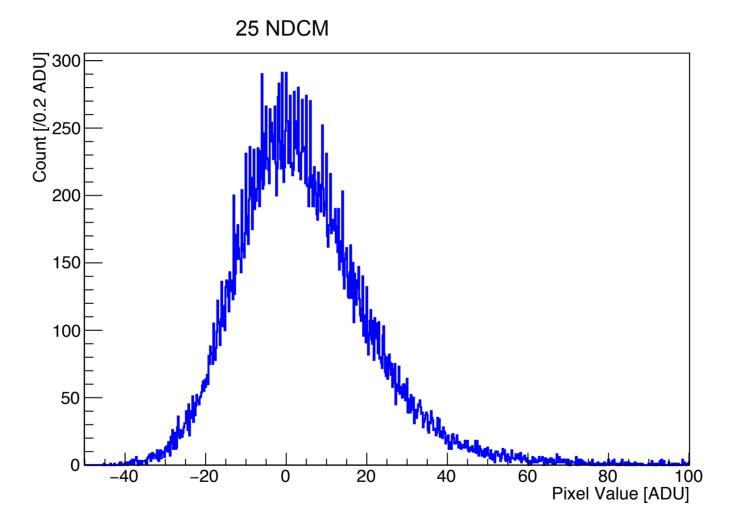
low frequency noise **Regular CCD**

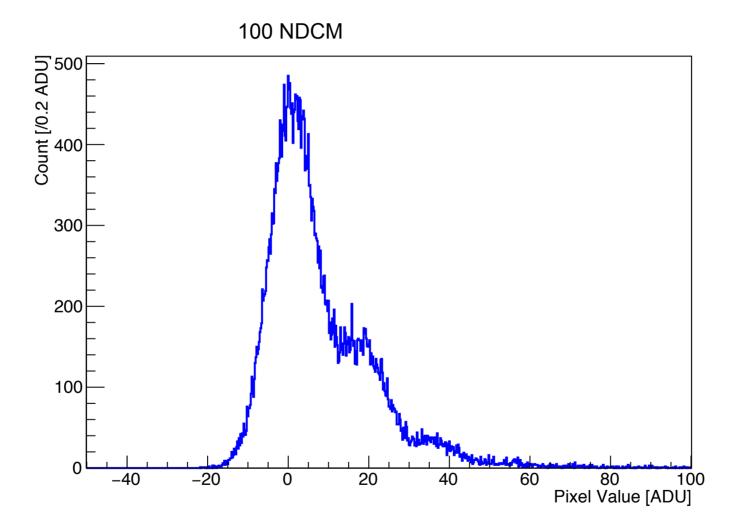
signal

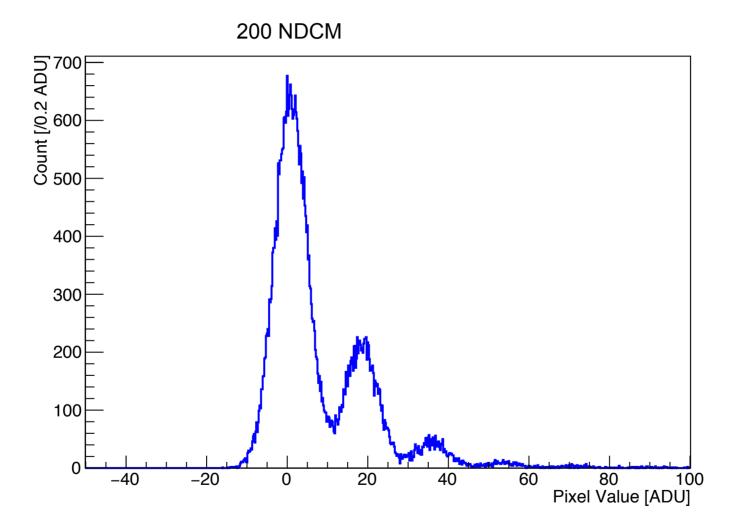


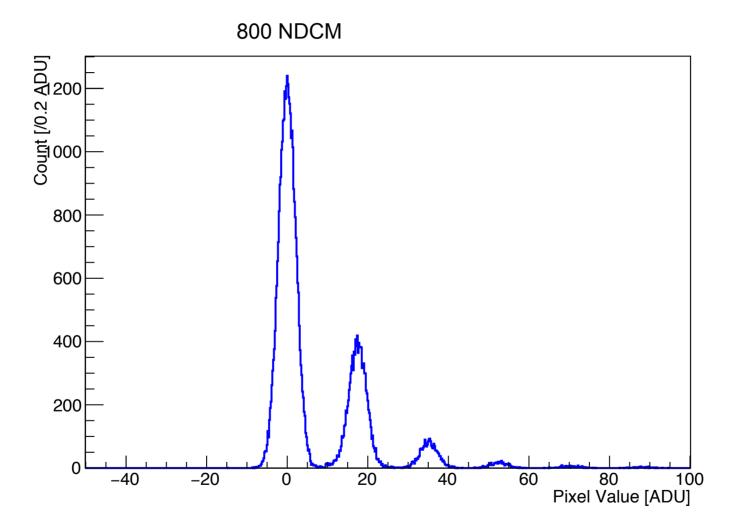


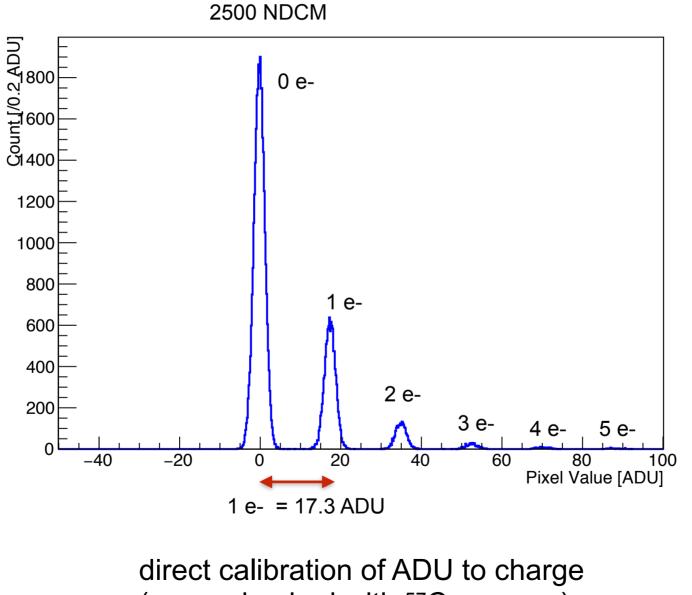






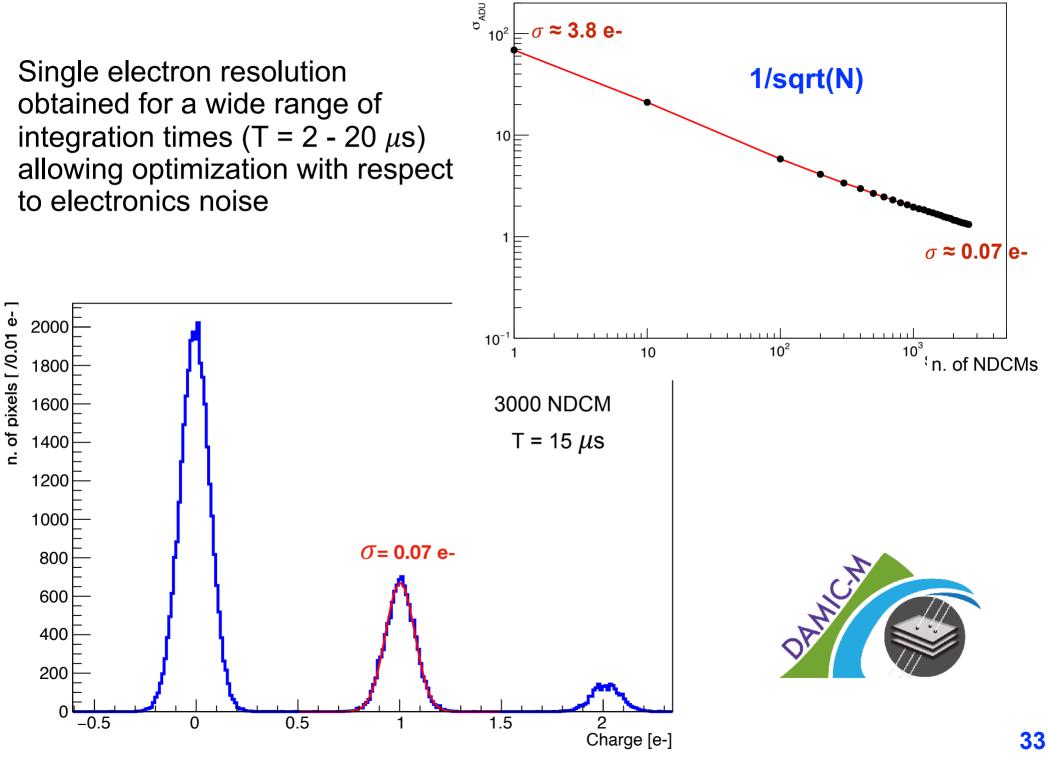




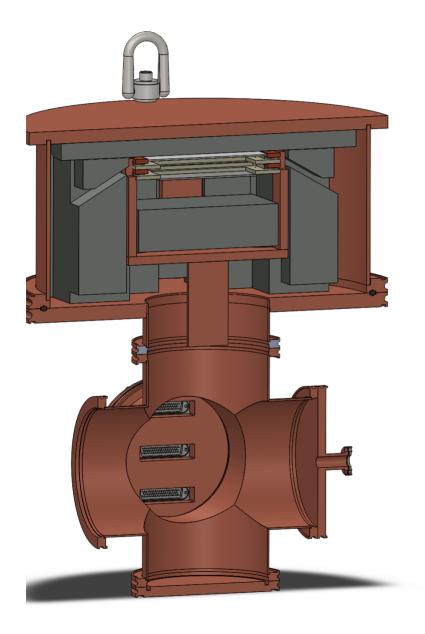


(cross checked with ⁵⁷Co source)

Single electron resolution obtained for a wide range of integration times (T = 2 - 20 μ s) to electronics noise



Low Background Chamber



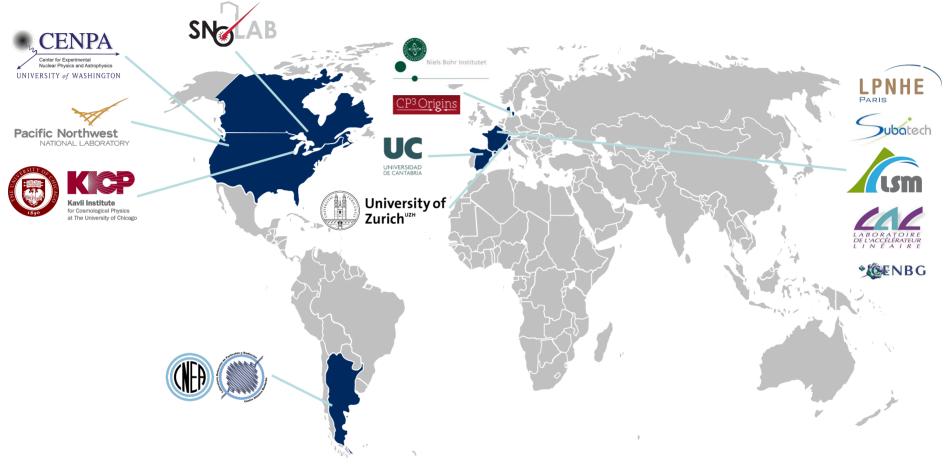
- A low-background chamber (background level ≈ dru) is in preparation
- Main objectives:
 - characterization of DAMIC-M CCDs in low-bkg environment: dark current;
 ³²Si rate; ²¹⁰Pb surface bkg;
 CCD packaging
 - first science results with a few CCDs
- Installation at LSM beginning of 2020

Outlook

- DAMIC-M is pushing to a kg-size detector the high-resistivity, fullydepleted CCD technology pioneered at SNOLAB
- The experiment is in its design phase. Progress on all aspects: detector design, electronics, low-background
- Major milestones accomplished: silicon ingot production; demonstration of single electron resolution with large-size, thick CCDs implementing skipper design
- We are moving fast. Before the end of this year, installation of DAMIC-M clean room at LSM and CCD pre-production. CCD production scheduled for next year.
- A low-background chamber will be installed at the LSM beginning of 2020 to characterize DAMIC-M skipper CCDs underground in a low background environment. Early science results with a few CCDs are foreseen.
- We are already thinking about next step: R&D for a 10-kg detector based on the skipper technology has recently been funded by DOE (FOA *Dark Matter New Initiatives*; DAMIC-M and SENSEI US groups joined effort)

DAMIC-M Collaboration









established by the European Commission





FONDS NATIONAL SUISSE Schweizerischer Nationalfonds Fondo nazionale svizzero Swiss National Science Foundation